

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Ikuo Nishimoto et al.
Application No. : 10/538,980
Date of Filing : June 14, 2005
Title : APPARATUS AND METHOD OF EXPOSING LIGHT
TO A SEMICONDUCTOR DEVICE HAVING A
CURVED SURFACE
Confirmation No. : 9472
Examiner : Mathews, Alan A.
TC/Art Unit : 2851
USPTO Customer No. : 26707
Attorney Docket No. : 981045.90011

RESPONSE UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 13, 2006,
Applicant(s) respectfully request the Examiner to reconsider and
further examine the Application in view of the amendments and/or
comments as set forth below.

Amendments to the Specification: None.

Amendments to the Claims: Begin on page 2.

Amendments to the Drawings: None.

Remarks: Begin on page 8.